



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 1605

Tadahiro OHMI et al.

Group Art Unit: 1763

Application No.: 09/864,376

Examiner: Rudy ZERVIGON

Filed: May 25, 2001

Attorney Docket No.: 107176-00007

For: PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD

RESPONSE UNDER 37 C.F.R § 1.111

Mail Stop AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

October 16, 2006

Sir:

In reply to the outstanding Office Action dated July 14, 2006 (October 14, 2006, falling on a Saturday), please amend the application as shown on the following pages:

Amendments to the **Claims** begin on page 2.

The **Remarks** begin on page 15.